



BUCKET NO: 220033US90

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF: :
Fuyuhiko INOUE, et al. : EXAMINER: STAFIRA, M. P.
SERIAL NO.: 10/080,537 :
RCE FILED: Herewith : GROUP ART UNIT: 2877
FOR: WAVEFRONT ABERRATION :
MEASURING METHOD AND
UNIT, EXPOSURE
APPARATUS, DEVICE
MANUFACTURING
METHOD, AND DEVICE

AMENDMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Notice of Allowance dated March 19, 2004, please amend the
above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on
page 31 of this paper.

Remarks/Arguments begin on page 41 of this paper.

06/23/2004 HVUON61 00000051 10080537

02 FC:1201
03 FC:1202

86.00 OP
198.00 OP